

the **abdus salam** international centre for theoretical physics

ICTP 40th Anniversary

SMR 1564 - 13

SPRING COLLEGE ON SCIENCE AT THE NANOSCALE (24 May - 11 June 2004)

Biological Applications of Scanning Probe Microscopy (SPM)

Introduction to Atomic Force Microscopy

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These are preliminary lecture notes, intended only for distribution to participants.





Introduction to Atomic Force Microscopy

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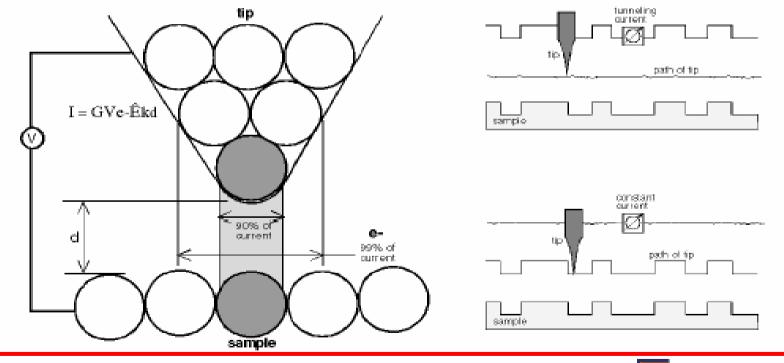




ACKNOWLEDEGEMENTS: YING HU and GANG YU LIU (U.of C. Davis) who kindly provided several images for this lecture

Scanning Tunneling Microscope

 The scanning tunneling microscope (STM) is the ancestor of all scanning probe microscopes. It was invented in 1981 by Gerd Binnig and Heinrich Rohrer at IBM Zurich. Five years later they were awarded the Nobel prize in physics for its invention. The STM was the first instrument to generate real-space images of surfaces with atomic resolution.

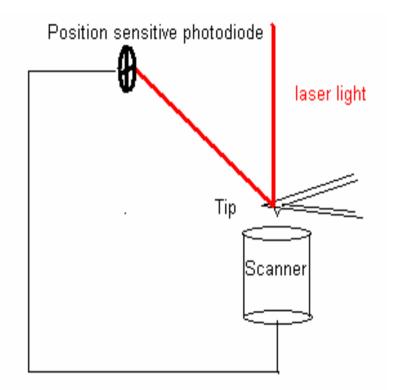


The tip-surface interaction is highly local --at atomic/molecular level or better.

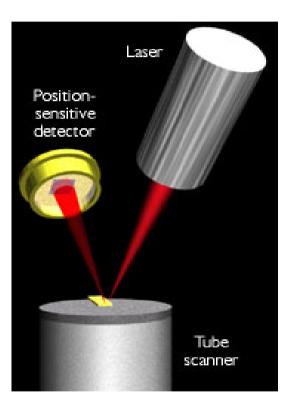
→ How to control such local interaction to do high resolution imaging?

→ How to control such local interaction to do high precision scanning probe lithography?

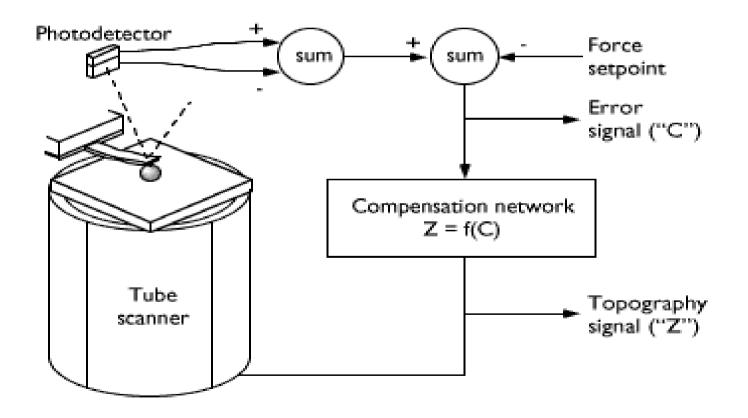
Are there any other methods (other than tunneling) to monitor the position of a sharp tip on a surface?



Feedback loop



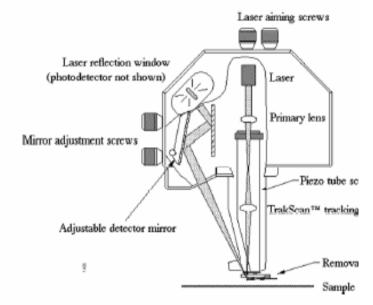
AFM also uses feedback to regulate the force on the sample



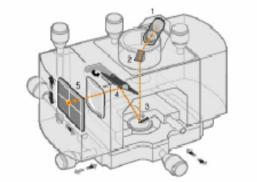
13.0 SPM Configurations

Scanned Tip SPM

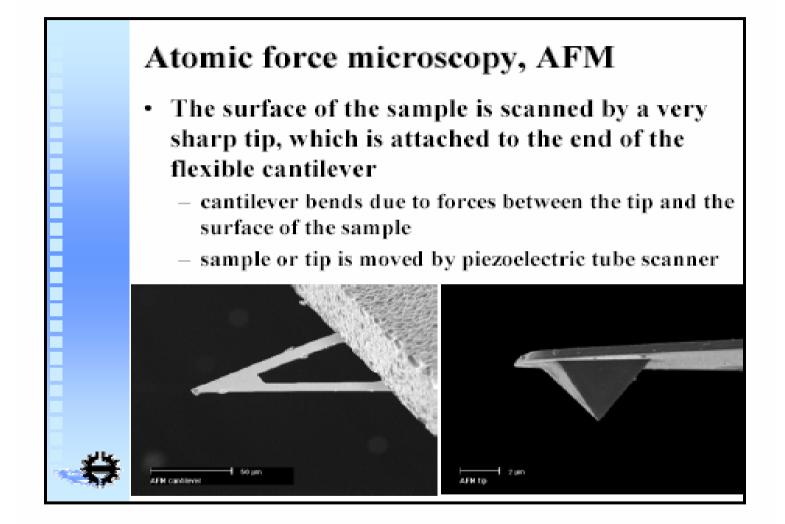




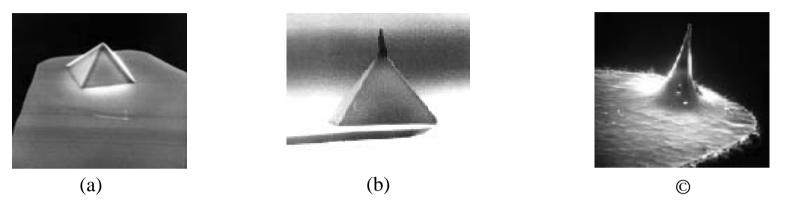
Scanned Sample SPM



Labels: 1. Laser 2. Mirror 3. Cantileve 4. Tilt mirro 5. Photodete



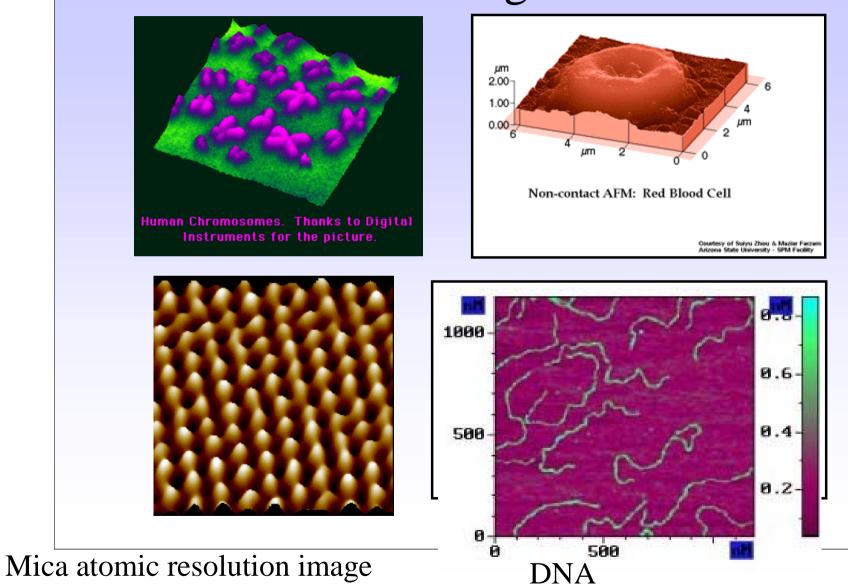
Some commercially available tips configuration



Three common types of AFM tip. (a) normal tip $(3 \mu m \text{ tall})$; (b) supertip; (c) Ultralever (also $3 \mu m \text{ tall})$. Electron micrographs by Jean-Paul Revel, Caltech.

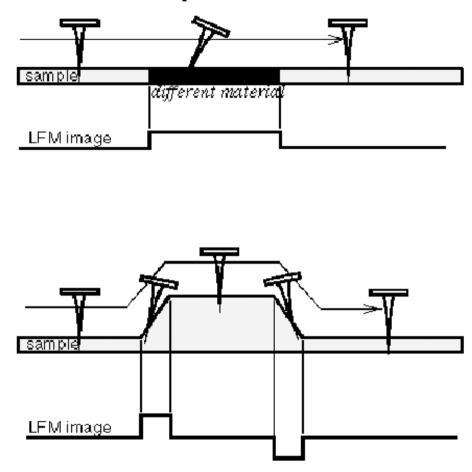
- Tips are generally evaluated by their "end radius" which limits the resolution of AFM.
- The "normal tip" (Albrecht et al., 1990) is a 3 μ m tall pyramid with ~30 nm end radius.
- The electron-beam-deposited (EBD) tip or "supertip" offers a higher aspect ratio (it is long and thin, good for probing pits and crevices) and sometimes a better end radius than the normal tip.
- The "Ultralever" is based on an improved microlithography process. Ultralever offers a moderately high aspect ratio and on occasion a ~10 nm end radius.

AFM Images

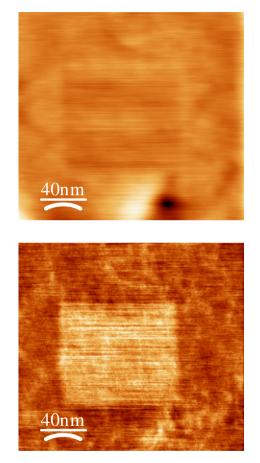


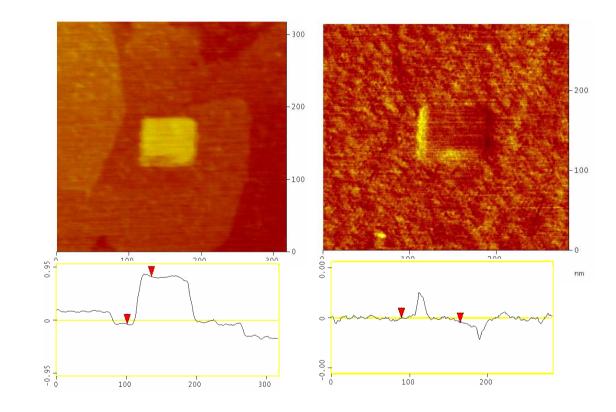
Lateral Force Microscope

- Lateral force microscopy (LFM) measures lateral deflections (twisting) of the cantilever that arise from forces on the cantilever parallel to the plane of the sample surface. LFM studies are useful for imaging variations in surface friction that can arise from inhomogeneity in surface material, and also for obtaining edge-enhanced images of any surface.
- Lateral deflections of the cantilever usually arise from two sources: changes in surface friction and changes in slope.



Dip Pen Nanografting

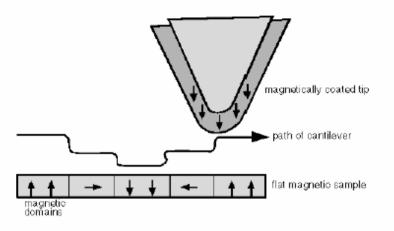




SH-(CH2)14-CF3 nanografted into SH-(CH2)17-CH3 layers (2000Å×2000Å) in air Topographic DataLateral Force Data C_{18} pattern written into C_{10} matrixJordan Amadio(2002)

Magnetic Force Microscope

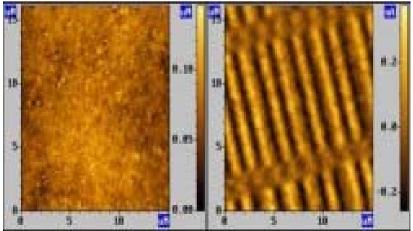
- Magnetic force microscopy (MFM) images the spatial variation of magnetic forces on a sample surface. For MFM, the tip is coated with a ferromagnetic thin film. The system operates in noncontact mode, detecting changes in the resonant frequency of the cantilever induced by the magnetic field's dependence on tip-to-sample separation. MFM can be used to image naturally occurring and deliberately written domain structures in magnetic materials.
- An image taken with a magnetic tip contains information about both the topography and the magnetic
 properties of a surface





Hard-disk service. Field of view

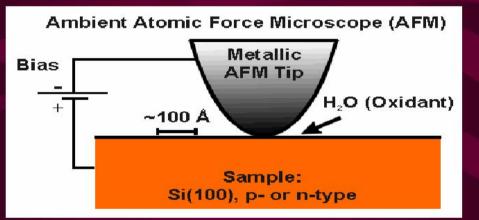
is 30 μm .



Hard disk

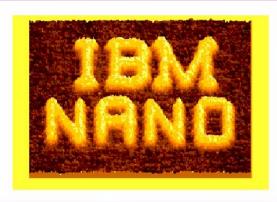
Local Oxidation

• The AFM-tip induced oxidation process is based on negatively biasing the tip with respect to the substrate under ambient conditions, which can be either a semiconductor or a metal.

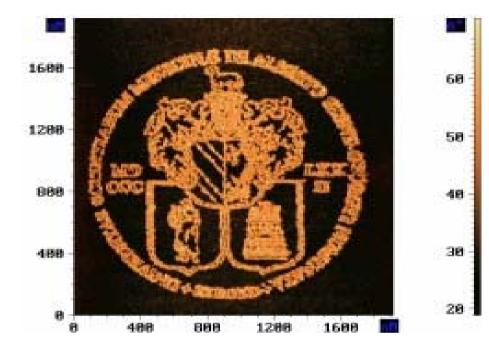


• The substrate locally oxidizes upon moving the tip in contact mode across the surface.

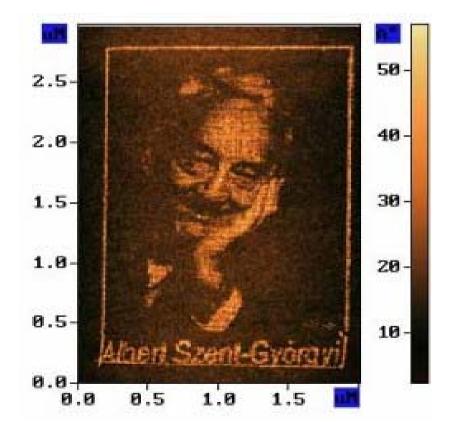
Example of Local Oxidation



• The atomic-force microscope (AFM) image above gives an example where oxide lines of about 20 nm width were used to define the silicon dioxide pattern "IBM NANO" on a silicon wafer.



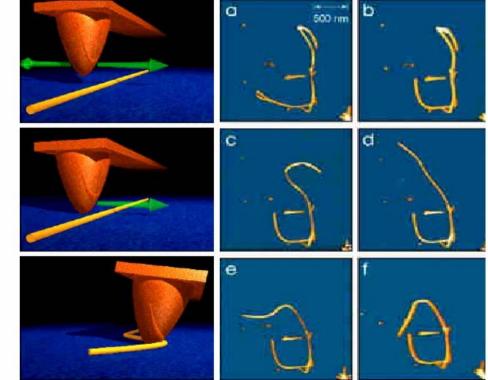
Examples of local oxidation



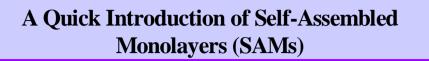
MANIPULATION is DIFFICULT but POSSIBLE

Micro Nano Manipulation

- IBM nanotube manipulation for position nanotube on transistors.
- http://www.resea rch.ibm.com/nan oscience/nanotub es.html

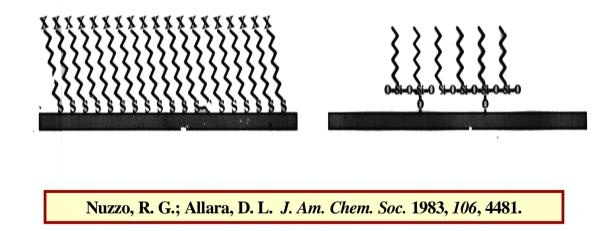


CHEMICAL APPLICATIONS



Thiol Self-assembled Monolayer on Au(111) 0

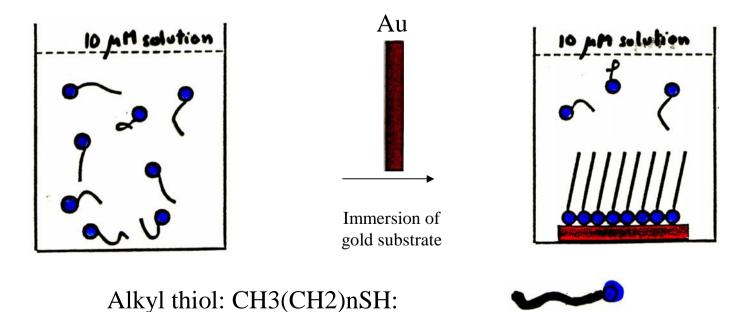
OTE Self-assembled Monolayer on Mica



Membrane-like monolayers: 1) Langmuir 2) Langmuir-Blodgett 3) Preparation of Thiol SAMs (Self-Assembled Monolayers) on Au(111)

Solution Deposition

We prepare a thiol monolayer by placing a clean gold(111) substrate in less than 0.1 micromolar ethanolic thiol solution for 18 hours.

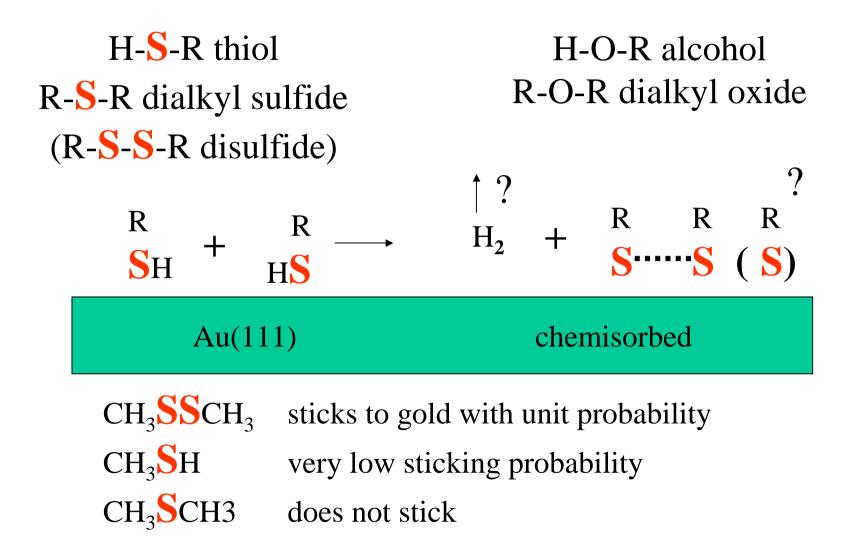


A Quick Introduction of Self-Assembled Monolayers (SAMs)

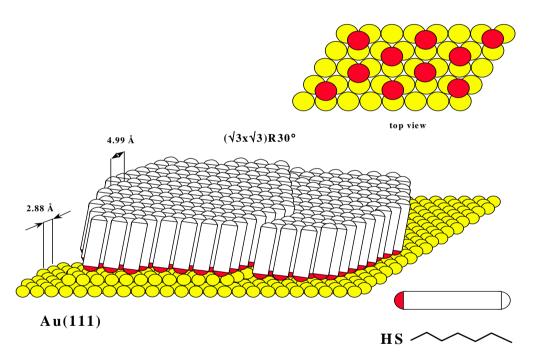
Bond energy

- C-C: 145 kcal/mol
- C-S: 171 kcal/mol
- C-H: 81 kcal/mol
- S-Au: 40 kcal/mol
- van der Waals energy per CH₂ group is ~ 1.5 kcal/mol

THE ADSORPTION of ALKYLTHIOLS on GOLD



A Quick Introduction of Self-Assembled Monolayers (SAMs)



Self-assembled monolayers of alkanethiols on gold are much studied systems because:

- 1) Very stable and easily formed
- 2) Frequently used for electrode surface modification (Chemical SENSORS)
- 3) Model systems for interfacial electron transfer
- 4) Soft lithography & surface patterning (micro printing)
- 5) Model systems for surface passivation against corrosion (also bio passivation).
- 6) Model systems for study of friction
- 7) Colloid coating and linking for cluster-based materials
- 8) Suitable films for nanografting (i.e. locally induced chemistry)
- Last but not least, SAMs have, recently, become the building blocks of a new wave of promising molecular electronic devices (FETs, switches etc).

During the last 10 years we have dealt extensively, using X-rays, atom diffraction and SPM, with issues like:

1) Structure

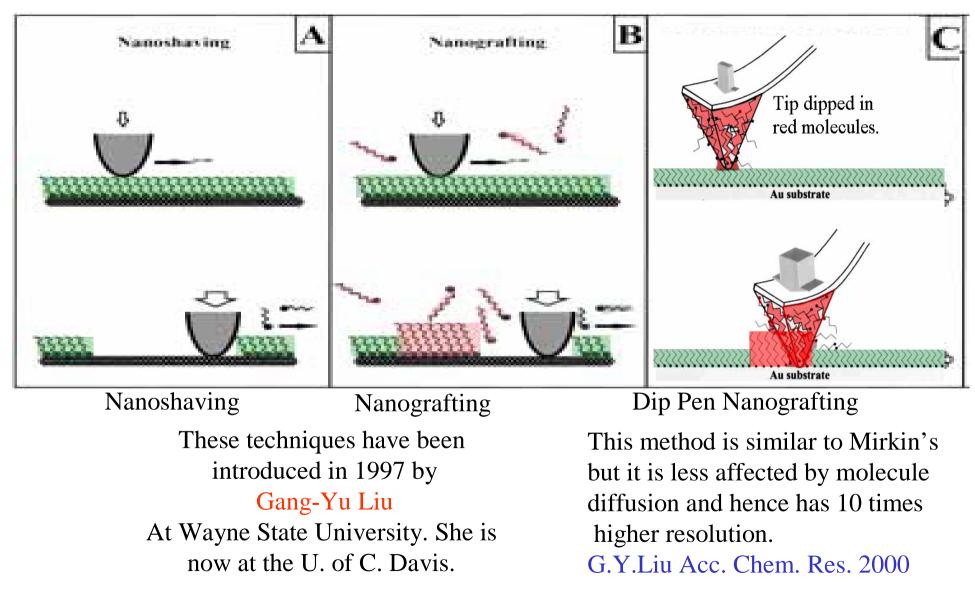
2) Kinetics of growth

3) Manipulation at the nanoscale

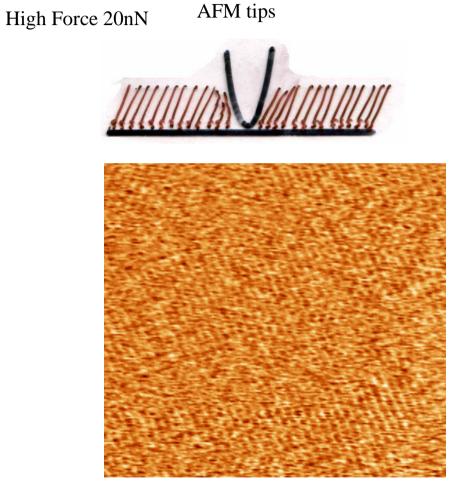
The third topic is the focus of today's talk.

Surface Manipulation

Three powerful methods to manipulate the chemical composition of surfaces on the nanoscale.



How do we know how much force to use?



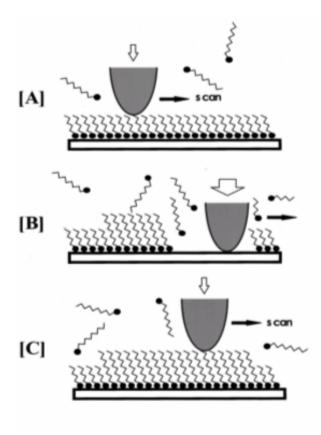
Atomic resolution image of gold(111) (100 Å \times 100 Å)

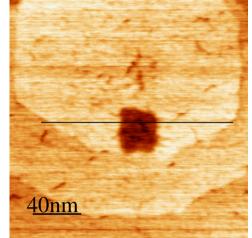


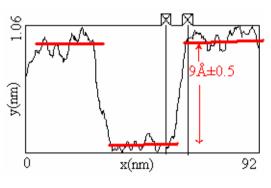
Molecular resolution image of C18 (100 Å ×100 Å)

BASIC NANOGRAFTING

In solution:

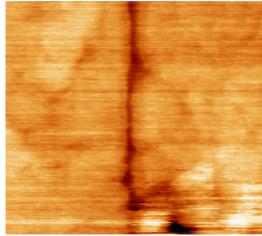






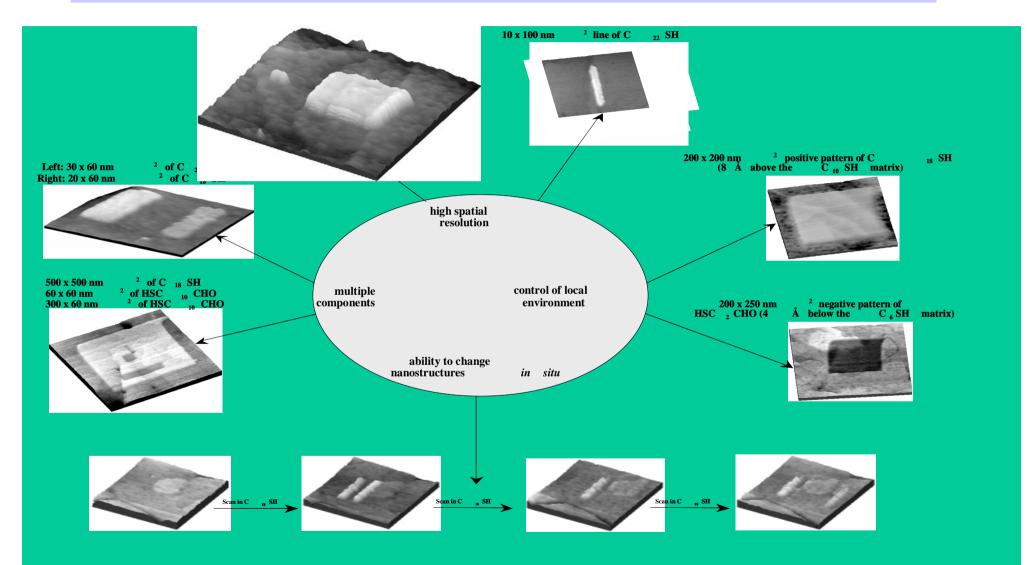
Expected height difference: 8.7Å

 C_{10} nanografted into a C_{18} SAM (400 Å ×400 Å)

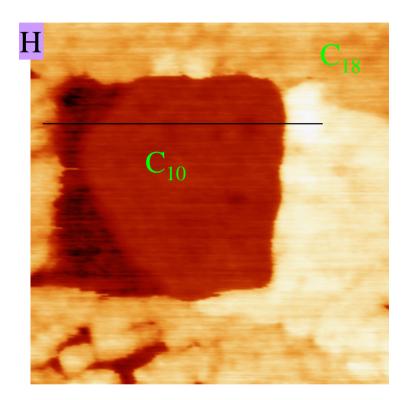


A 70 Å "line" of C₁₀ nanografted into a C₁₈ SAM (800 Å × 800 Å)

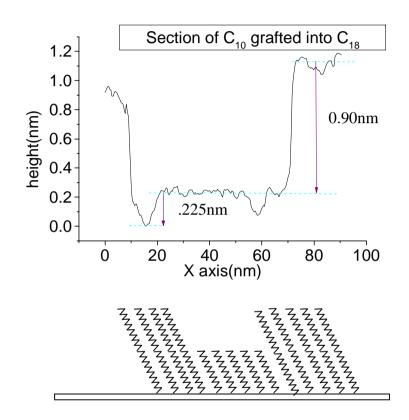
Example nanostructures of organic molecules



An Example of Nanografting



 C_{10} grafted into C_{18} (100nm×100nm) and the corresponding height measurement

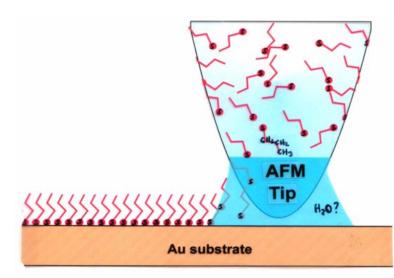


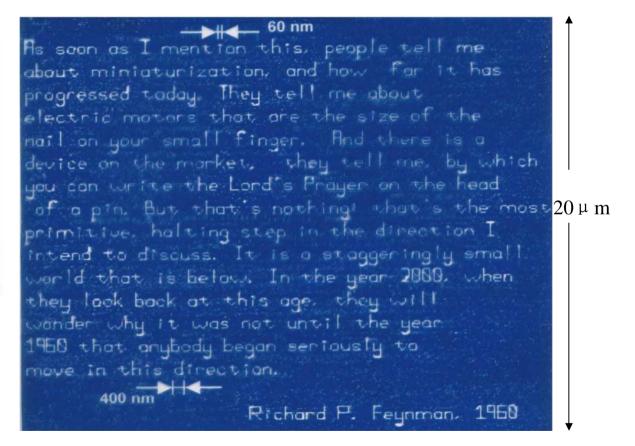
Calculated height measurement between C_{10} and C_{18} is 0.86 nm.

(Ying Hu 2002) Princeton

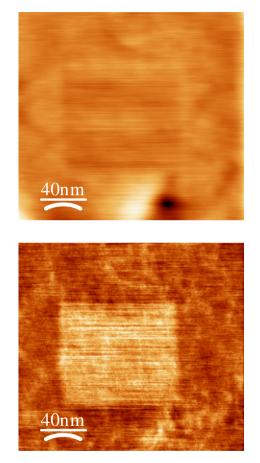
Dip-Pen Nanolithography

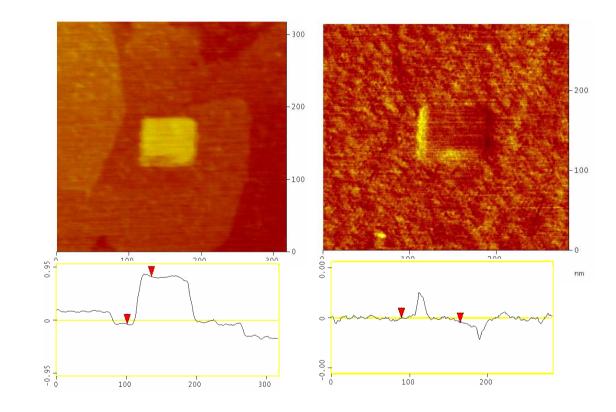
C.Mirkin and Coll. Science, 2000





Dip Pen Nanografting



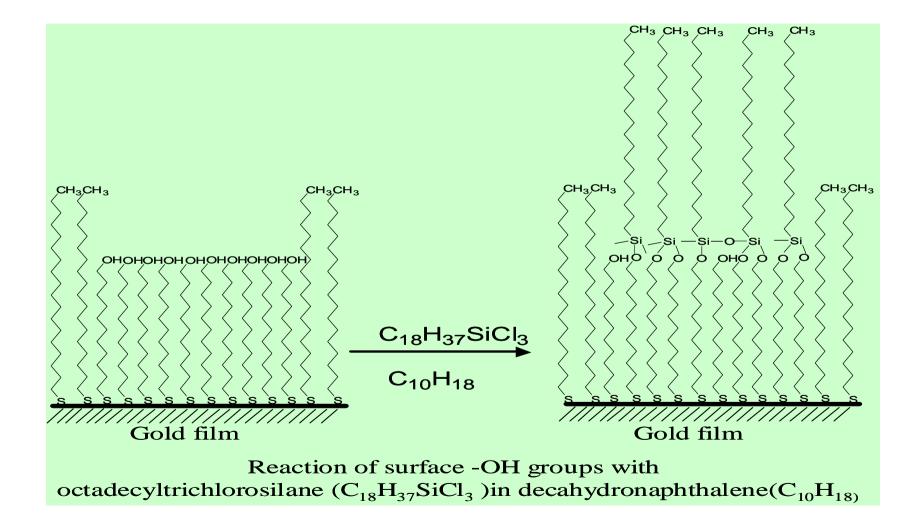


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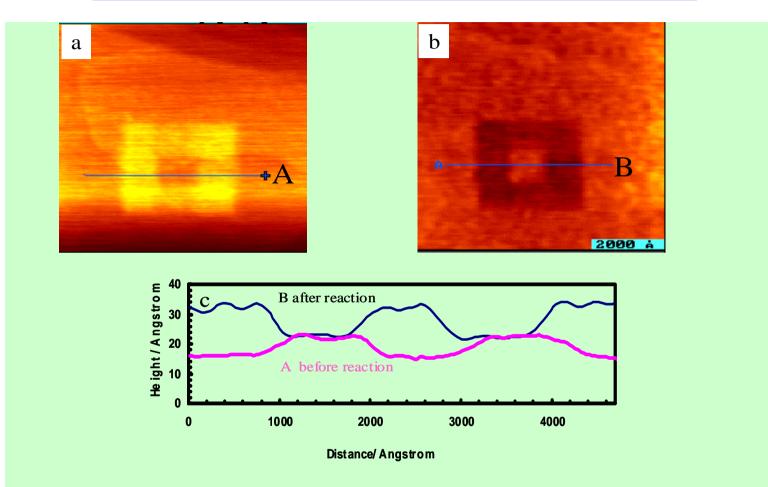
Construction of 3D Nanostructures

Pattern transfer via surface reactions

Construction of 3D Nanostructures



Construction of 3D Nanostructures



AFM images (a, b) and height-distance plots (c) before (a) and after (b) reaction of the surface hydroxyl groups with 11 mM octadecyltrichlorosilane in decahydronaphthalene